

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sung-Jin KIM, et al.

Serial No.: 10/685,655 Examiner: Vu, Hung K.

Filed: October 14, 2003 Group Art Unit: 2811

Confirmation No.: 5662

For: PHOTO MASK SET FOR FORMING MULTI-LAYERED
INTERCONNECTION LINES AND SEMICONDUCTOR DEVICE
FABRICATED USING THE SAME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 112006, dated November 15, 2006, please amend the application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.